

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

HU et al.

Application No. 09/924,265

Filed: August 7, 2001



Confirmation No. 4890

Group Art Unit: 3736

Examiner: J. Hoekstra

For: **SYSTEM AND METHOD FOR VISION EXAMINATION UTILIZING FAULT  
DETECTION**

**RESPONSE UNDER 37 CFR §1.114**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a full and complete response to the Office Action having a mailing date of June 4, 2008. The three month shortened statutory period to respond to the Office Action was set to expire September 4, 2008. As such a petition for a one month extension of time is included with this paper.

In view of the following remarks and amendments, Applicants respectfully request that the Examiner reconsider and withdraw the outstanding rejections and allow this application.